

Attorney Docket No. 03663/LH

This paper is being submitted
via EFS-Web on December 15, 2006

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Tomio MATSUZAKI et al
Serial No. : 10/700,136
Conf. No. : 3722
Filed : November 3, 2003
For : WIRING STRUCTURE ON
SEMICONDUCTOR SUBSTRATE
AND METHOD OF FABRICATING
THE SAME
Art Unit : 2811
Examiner : Steven Ho Yin Loke

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not already paid, authorization to charge the extension fee to Account No. 06-1378. In addition, authorization is hereby given to charge any fees for which payment has not been submitted, or to credit any overpayments, to Account No. 06-1378.

A M E N D M E N T

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R :

This is responsive to the Office Action mailed June 15, 2006, the term for response to which is extended by three months by Petition filed herewith to expire on December 15, 2006.

Amendments to the Claims are set forth in the listing of claims which begins on page 2 of this paper. Claims 1, 3, 36, 37, 48 and 51-53 are amended; claims 2, 17-35, and 40-45 are canceled; and claims 4-16, 38, 39, 46, 47, 49 and 50 are maintained.

Remarks begin on page 12 of this paper.